



Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Complete if Known		
Application Number			10/517,942		
Filing Date					
First Named Inventor			Manger, Ian D.		
Art Unit			Not yet known		
Examiner Name			Not yet known		
Attorney Docket Number			020174-008610US		
Sheet	1	of	7		

U.S. PATENT DOCUMENTS+					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number Kind Code ² (if known)			
	A1	US-3,570,515	03-16-1971	Kinner	
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	A40	US-6,007,309	12-28-1999	Hartley	
Examiner Signature	/Paul Hyun/			Date Considered	06/08/2009

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		Country Code ³	Number ⁴	Kind Code ⁵ (if known)				
	B1	EPO	EP 0 592 094	A2	04-13-1994			<input type="checkbox"/>
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	B8	GB	2 155 152	A	09-18-1985			<input type="checkbox"/>
	B9	GB	2 308 460	A	06-25-1997			<input type="checkbox"/>
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	B11	PCT	WO 99/00655	A2	01-07-1999			<input type="checkbox"/>
	B12	PCT	WO 99/04361	A1	01-28-1999			<input type="checkbox"/>
	B13	PCT	WO 99/17093	A1	04-08-1999			<input type="checkbox"/>
	B14	PCT	WO 99/52633	A1	10-21-1999			<input type="checkbox"/>
	B15	PCT	WO 00/00678	A1	01-06-2000			<input type="checkbox"/>
	B16	PCT	WO 00/43748	A1	07-27-2000			<input type="checkbox"/>
	B17	PCT	WO 00/60345	A1	10-12-2000			<input type="checkbox"/>
	B18	PCT	WO 01/01025	A2	01-04-2001			<input type="checkbox"/>

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Examiner Signature	/Paul Hyun/	Date Considered	06/08/2009
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* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.